

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	773	(29/743).CCLS.	US-PGPUB; USPAT	OR	OFF	2009/12/26 16:38
S2	1387	(294/64.1).CCLS.	US-PGPUB; USPAT	OR	OFF	2009/12/26 16:56
S3	202	S2 and (nozzle)	US-PGPUB; USPAT; USOCR	ADJ	ON	2009/12/26 16:57
S4	0	("2003029029").PN.	US-PGPUB; USPAT	OR	OFF	2009/12/26 17:37
S5	1	("20030029029").PN.	US-PGPUB; USPAT	OR	OFF	2009/12/26 17:37
S6	10	("2390298" "3147017" "4559718" "4767142" "4875279").PN. OR ("6152506").URPN.	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/13 11:36
S7	27911	(h05k013/04.ipc. or h05k13/04.ipcr.)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2010/01/13 11:44
S8	6357	S7 and (vacuum or suction or sucking)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2010/01/13 11:45
S9	3129	S7 and (vacuum or suction or sucking).ti,ab.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; IBM_TDB	ADJ	ON	2010/01/13 11:46
S10	2622	S7 and (vacuum or suction or sucking).ti,ab.	FPRS; EPO; JPO; IBM_TDB	ADJ	ON	2010/01/13 11:46
S11	2244	suction port with shape	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2010/01/13 15:28

S12	31	suction port shape	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2010/01/13 15:28
S13	115	29/743 and cassette	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 18:58
S14	775	(29/743).CCLS.	US-PGPUB; USPAT	OR	OFF	2010/01/15 18:58
S15	775	S14	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 18:58
S16	80	S14 and cassette	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 18:58
S17	0	S13 and surface roughness	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 19:45
S18	2	S14 and surface roughness	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 19:45
S19	7	S14 and roughness	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 19:46
S20	44	"4794689"	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 21:22
S21	1	("4794689").PN.	US-PGPUB; USPAT	OR	OFF	2010/01/15 21:23
S22	5	(vacuum or suction) nozzle and semiconductor ceramic	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 22:38
S23	775	(29/743).CCLS.	US-PGPUB; USPAT	OR	OFF	2010/01/15 22:39
S24	1	S23 and semiconductor ceramic	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 22:39
S25	1810	semiconductor ceramic	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 22:40
S26	5	(vacuum or suction) nozzle and semiconduct \$3 ceramic	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 22:40
S27	872	(vacuum or suction) and semiconduct\$3 ceramic	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 22:40
S28	185	(vacuum or suction) and nozzle and semiconduct \$3 ceramic	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 22:41
S29	29	(vacuum or suction) with nozzle and semiconduct \$3 ceramic	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 22:41
S30	35	(vacuum or suction) nozzle and semiconduct \$3 near10 ceramic	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 22:43

S31	53	(vacuum or suction) and nozzle with semiconductor\$3 with ceramic	US-PGPUB; USPAT; USOCR	ADJ	ON	2010/01/15 22:47
S32	1	wo "9833368"	DERWENT	ADJ	ON	2010/01/15 23:04
S33	299	vacuum and nozzle with semiconductor\$3	DERWENT	ADJ	ON	2010/01/15 23:08
S34	219	vacuum and nozzle near10 semiconductor\$3	DERWENT	ADJ	ON	2010/01/15 23:08
S35	126	vacuum and nozzle near5 semiconductor\$3	DERWENT	ADJ	ON	2010/01/15 23:08
S36	27911	(h05k013/04.ipc. or h05k13/04.ipcr.)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2010/01/15 23:09
S37	8	vacuum and nozzle near5 semiconductor\$3 and S36	DERWENT	ADJ	ON	2010/01/15 23:09

EAST Search History (Interference)

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1/ 16/ 2010 1:36:05 PM

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